

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1208		SERIAL NO. 09/388,826	
<div style="text-align: center;"> LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</div>				APPLICANT Weimin (Michael) Li et al.			
				FILING DATE September 1, 1999		GROUP 2813	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
EK ↑	AA	6,184,158 B1	02/01	Shufflebotham et al.	/	/	
	AB	6,096,656	08/00	Matzke et al.	/	/	
	AC	6,209,484 B1	04/01	Huang et al.	/	/	
	AD	6,440,860 B1	08/02	DeBoer et al.	/	/	
	AE	5,413,963	05/95	Yen et al.	/	/	
	AF	6,143,670	11/00	Cheng et al.	/	/	
	AG	6,403,464	06/02	Chang	/	/	
	AH	2001/0038919 A1		Berry, III et al. (Pub Date 11/01)	/	/	
	AI	2002/0033486 A1		Kim et al. (Pub Date 03/02)	/	/	
	EK	AJ	2002/0081834 A1		Daniels et al. (Pub Date 06/02)	/	/
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation *	
						Yes	No
EK ↑	AK	EP 1 172 845 A2	01/02	EP	/	/	
	AL	JP 08-213386 A	08/96	JP	/	/	
	AM	JP 2000068261 A	03/00	JP	/	/	
	AN	JP 09050993 A	02/97	JP	/	/	
	AO	TW 368687 A	09/99	TW	/	/	
	AP	TW 429473 A	04/01	TW	/	/	
	EK	AQ	TW 420844 A	02/01	TW	/	/
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
AR							
AS							
AT							
EXAMINER EK				DATE CONSIDERED 6/6/03			
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U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.  
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U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
EK	AA	4,562,091	12/31/85	Sachdev et al.			
	AB	4,764,247	08/16/88	Leveriza et al.			
	AC	5,940,509	07/10/90	Tso et al.			
	AD	6,200,835 B1	03/13/01	Manning			
	AE	5,244,537	09/14/93	Ohnstein			
	AF	4,910,160	03/20/90	Jennings et al.			
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EK	AI	5,986,318	11/16/99	Kim et al.			
	AJ						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AK							
	AL							
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	AP							
	AQ							

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EK	AR		Wolf et al., "Silicon Processing for the VLSI Era - Vol. 1 - Process Technology," Prologue, page xxiii (2 pages total).
	AS		
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EXAMINER  
E. K. Kim

DATE CONSIDERED  
6/6/03

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